



EL 979955752

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.08/846,671
Filing Date April 30, 1997
Inventorship Kei-Yu Ko
Assignee Micron Technology, Inc.
Group Art Unit 1763
Examiner George A. Goudreau
Attorney's Docket No. MI22-2041
Customer No. 021567
Title: Undoped Silicon Dioxide as Etch Stop for Selective Etch of Doped Silicon Dioxide

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

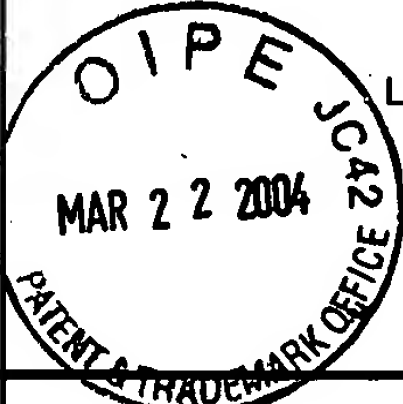
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are attached hereto. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a request for continued examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 3-22-04

By: 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2041		SERIAL NO. 08/846,671		
<div style="display: flex; align-items: center; justify-content: center;"><div style="text-align: center;"></div><div style="margin-left: 10px;">LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</div></div>				APPLICANT: Kei-Yu Ko				
				FILING DATE April 30, 1997		GROUP 1763		
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	4,672,740	06/16/87	Shirai et al.				
	AB	5,229,311	07/20/93	Lai et al.				
	AC	5,393,704	02/28/95	Huang et al.				
	AD	5,705,427	01/06/98	Chan et al.				
	AE							
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								